



IFul

Attorney Docket No. MXIC 1532-1

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Mail Stop Amendment, Commissioner for Patents, Post Office Box 1450, Alexandria, Virginia 22313-1450 on

November 2, 2004.

Paula Faulk Hurley

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| | |
|--|--|
| In re application of: Chih Yuan Huang Application No.: 10/621,120 Confirmation No.: 1938 Filed: July 16, 2003 Title: Method of Forming Silicon Film with Changing Grain Size by Thermal Process | Attorney Docket No.: MXIC 1532-1 Examiner: Andy Huynh Group: 2818 Customer No. 22470 |
|--|--|

RESPONSE A

Mail Stop Amendment
Commissioner for Patents
Post Office Box 1450
Alexandria, Virginia 22313-1450

Sir:

This RESPONSE A is in reply to the Office action mailed September 29, 2004. No fee is due.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.